

Appl. No. 09/802,693
Amdt. dated November 24, 2003
Reply to Office Action of June 25, 2003

PATENT

Amendments to the Specification:

Please replace the paragraph at page 1, lines 10-12 with the following amended paragraph:

U.S. Patent Application Serial No. 09/791,911 _____ "A Circuit Pattern
Inspection Method And Apparatus," by Takashi Hiroi, ~~et.~~ et al., filed February 22, 2001
(Attorney Docket No. 16869P-017800).